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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

KOUZNETSOV

Atty. Ref.: 2333-156

Serial No. Unknown 10/563864

TC/A.U.: Unknown 1795

Filed: January 9, 2006

Examiner: Unknown Michael Band

For: WORK PIECE PROCESSING BY PULSED ELECTRIC DISCHARGES IN
SOLID-GAS PLASMA

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January 9, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO/SB/08a. A copy of each listed foreign patent document and article is attached. The references were cited in the International Search Report for corresponding International Application No. PCT/SE2004/001129, a copy of which is being submitted with this IDS.

This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO/SB/08a and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

Respectfully submitted,

NIXON & VANDERHYE P.C.

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /M.B./

1030684

INFORMATION DISCLOSURE CITATION	ATTY. DOCKET NO.	SERIAL NO.
	2333-156	Unknown 10/563864
	APPLICANT	
	KOUZNETSOV	
(Use several sheets if necessary)	FILING DATE	TC/A.U.
	January 9, 2006	Unknown 1795

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

International Search Report for PCT/SE2004/001129 dated 2 November 2004.
Wang et al., *Tribological and optical properties of crystalline and amorphous alumina thin films grown by low-temperature reactive magnetron sputterdeposition*, Surface & Coatings Technology, vol. 146-147, 2001, pp 189-194.

*Examiner

/Michael Band/

Date Considered

10/20/2009

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /M.B./ 1030684